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Application No. 08/169,127
Docket No. 740756-945

1762

#58
M.L. Padgett
9/14/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor Patent Application of:
Hisato SHINOHARA et al.
Serial No. 08/169,127
Filed: 12/20/1993
For: METHOD AND SYSTEM OF LASER PROCESSING)

Examiner: M. L. Padgett
Group Art Unit: 1762

**REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENTS AND
INFORMATION DISCLOSURE STATEMENT**

RECEIVED
SEP 11 2002
TC 1700

Commissioner for Patents
Washington, DC 20231

Sir:

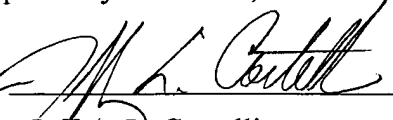
It is respectfully requested that the Examiner evidence consideration of the references cited in the IDS of February 19, 1999 and December 7, 1999 by providing a copy of the initialed Form PTO-1449. Courtesy copies of the references are enclosed, as well as new Form PTO-1449's consisting of Sheets 1/1 and 1/1..

Applicants also submit additional references for consideration by the Examiner that were cited in family applications of the subject application. These references are listed on the remaining sheets of the Form PTO-1449. Consideration of these references is respectfully requested. Copies of these references are also provided herewith.

In addition EP 0 322 258 published June 28, 1989, claims the priority date of Japanese application No. 62-327663, which is one of the priority Japanese applications of the subject application. It is respectfully requested that the Examiner review this publication carefully.

A check in the amount of \$180 is enclosed to cover the cost for filing the instant Information Disclosure Statement. The Commissioner is hereby authorized to charge any additional fees connected with this filing, which may be required now, or credit any overpayment to Deposit Account No. 19-2380 (740756-945).

Respectfully submitted,

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